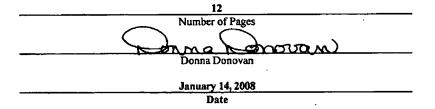
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of: 2771-594-CIP-RCE Docket No.: WANG, Ziyun, et al. Conf. No.: 1841 **Applicants: Art Unit:** 1621 10/699,079 **Application No.:** Samuel A. Barts Examiner: November 14, 2002 Date Filed: Customer No.: **COMPOSITION AND** Title: METHOD FOR LOW 23448 **TEMPERATURE DEPOSITION OF SILICON-CONTAINING FILMS**

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Samuel A. Barts Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission, addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, and transmitted on the date specified below, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.



RESPONSE TO NOVEMBER 27, 2007 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 10/699,079

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

2771-594-CIP-RCE

This responds to the November 27, 2007 Office Action in the above-identified application.

For ease of reference, a complete listing of the claims pending in the application, claims 1-31, is set out in Section I (Listing of the Claims) beginning on page 3 hereof.

Remarks concerning the amendments to the claims and the substance of the November 27, 2007 Office Action are set out in Section II (Remarks) beginning on page 7 hereof.